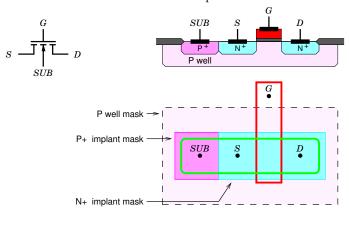
CMOS

NMOS Transistor – with top substrate connection



4001

CMOS

NMOS Transistor – with top substrate connection

Where it is not suitable for substrate connections to be shared, a more complex process is used.

- Five masks must be used to define the transistor:
 - P Well
 - Active Area
 - Polysilicon
 - N+ implant
 - P+ implant
- P Well, for isolation.
- Top *substrate* connection.
- P+/N+ implants produce good *ohmic* contacts.

CMOS Inverter N-well Active Area N implant Polysilicon Contact Window Metal 4003

CMOS

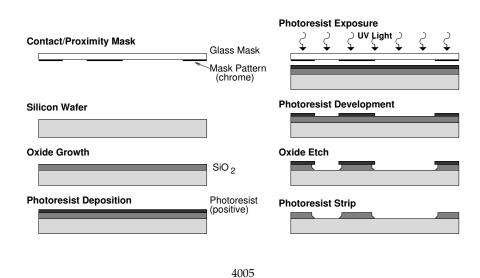
CMOS Inverter

- The process described here is an *N Well process* since it has only an N Well. P Well and Twin Tub processes also exist.
- Note that the P-N junction between chip substrate and N Well will remain reverse biased.

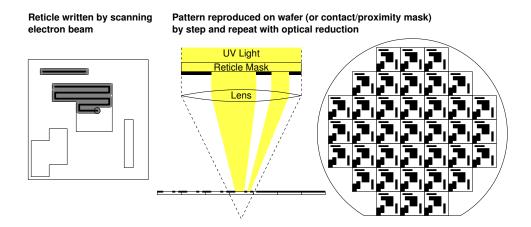
Thus the transistors remain isolated.

- N implant defines NMOS source/drain and PMOS substrate contact.
- P implant defines PMOS source/drain and NMOS substrate contact.

Processing – Photolithography



Processing – Mask Making



• Optical reduction allows narrower line widths.

4006

